캐비넷저장 | 캐비넷보기

(54) SEMICONDUCTOR INTEGRATED CIRCUIT AND MANUFACTURING METHOD THEREFOR

- (19) 국가 (Country) : JP (Japan)
- (11) 공개번호 (Publication Number) : **2001-094056** (2001.04.06) ▸日本語/한글(JP) ▸현재진행상태보기
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- (71) 출원인 (Applicant) : VICTOR CO OF JAPAN LTD
- (57) 요약 (Abstract) :

PROBLEM TO BE SOLVED: To provide a semiconductor integrated circuit that can be manufactured with a simple process and less manufacturing costs, so that a solution used in the process can be subjected easily to waste liquid treatment.

SOLUTION: In this semiconductor integrated circuit with a semiconductor integrated circuit, where a semiconductor element is formed and a protective film formed on the semiconductor integrated circuit, the protective film is made of an inorganic insulation film and an organic insulation resin with positive photosensitive property.

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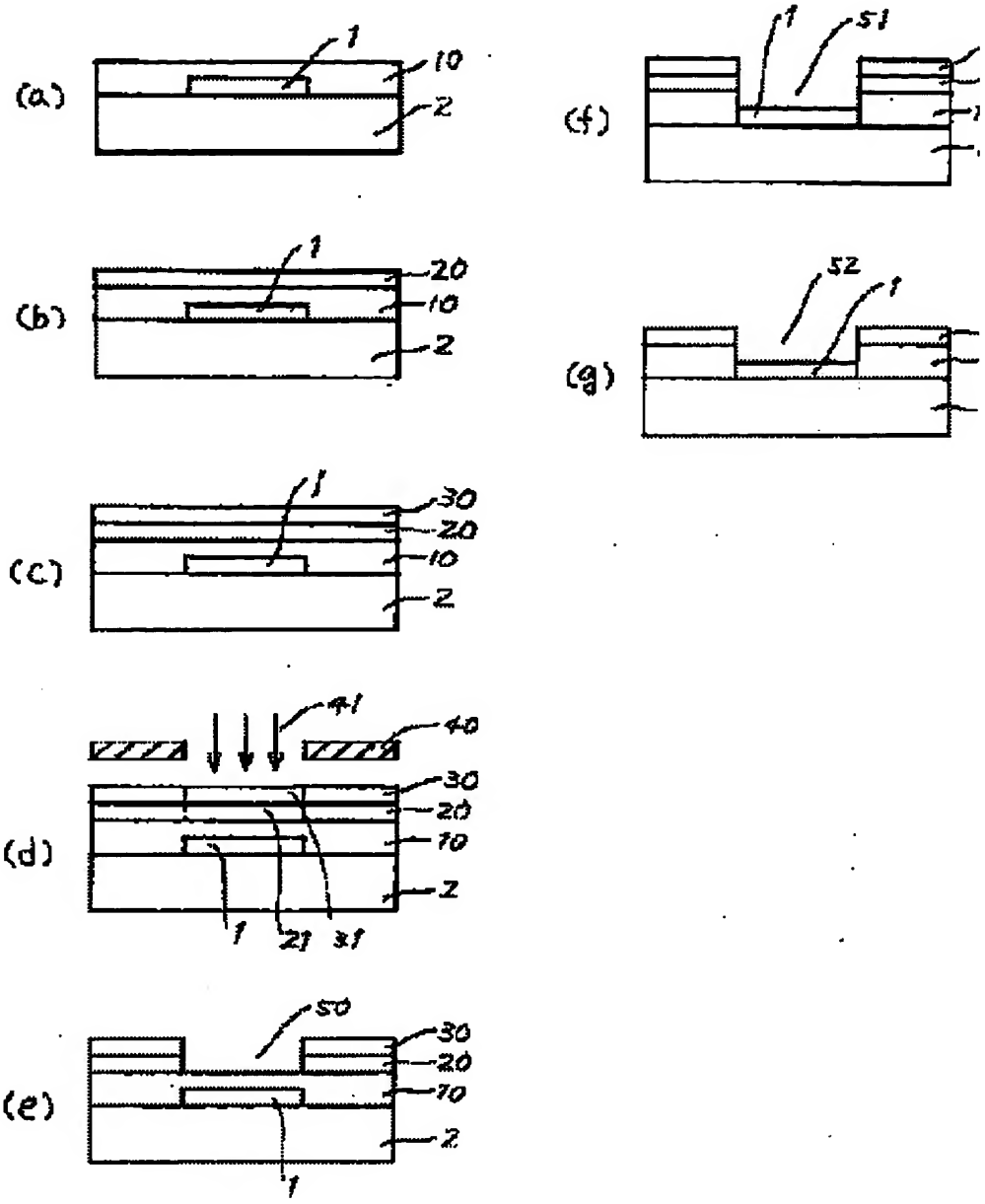

- INPADOC 패밀리 (Family 1) :

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☑ 선택된 패밀리특허 캐비넷 저장 Basic

특허포대신청